

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Hiroki TANAKA

Appln. No.:

Group Art Unit: Unknown

Filed: October 31, 2000

Examiner: Unknown

For: FIXED PATTERN DETECTION APPARATUS

**PRELIMINARY AMENDMENT**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Prior to examination, please amend the above-identified application as follows:

**IN THE SPECIFICATION:**

Page 11, line 12, change "Fig. 4 is a schematic view" to --Figs. 4(a), (b) and (c) are

schematic views--.

Page 11, line 20, change "Fig. 8 is a schematic view" to --Figs. 8(a) and (b) are schematic

views--.

Page 12, line 4, change "Fig. 13 is a schematic view" to --Figs. 13(a), (b) and (c) are

schematic views--.